

REPLY UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE **EXAMINING GROUP 2811**

PATENT 0649-0901P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Takeshi MISAWA

Conf.:

9184

Appl. No.:

10/620,461

Group:

2811

Filed:

July 17, 2003

Examiner: Thomas J. MAGEE

For:

SEMICONDUCTOR DEVICE AND METHOD FOR

AMNUFACTURING SAME

LARGE ENTITY TRANSMITTAL FORM FOR REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 November 12, 2004

Sir:

Transmitted herewith is an Amendment After Final in the above-identified application.

The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.

The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	16	-	20	=	0	\$ 18	\$0.00
INDEPENDENT	3	-	3	=	0	\$ 88	\$0.00
FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					\$300	\$0.00	
						TOTAL	\$0.00

	Petition for () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.						
\boxtimes	No fee is required.						
	Check(s) in the amount of \$0.00 is(are) enclosed.						
	Please charge Deposit Ac \$0.00. This form is submitte	ecount No. 02-2448 in the amount of d in triplicate.					
Accou	future replies, to charge pay	ner is hereby authorized in this, concurrent, ment or credit any overpayment to Deposit ional fees required under 37 C.F.R. §§1.16 or e fees.					
		Respectfully submitted,					
		BIRCH, STEWART, KOLASCH & BIRCH, LLP					
		ByMichael R. Cammarata, #39,491					
•	/ĈĴB:cb -0901P	P.O. Box 747 Falls Church, VA 22040-0747 (703) 205-8000					
Attac	hment(s)						



MS AF REPLY UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE **EXAMINING GROUP 9184**

> PATENT 0649-0901P

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SEMICONDUCTOR DEVICE AND METHOD FOR

MANUFACTURING THE SAME

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 November 12, 2004

Sir:

In reply to the Office Action dated August 12, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Remarks.